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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Chang Gyu KIM et al.

Korean Application No. 2001-15415

Korean Filing Date: March 24, 2001

Serial No.: 10/001,314

Filed: November 14, 2001

) METHOD FOR FORMING ISOLATION
) LAYER OF SEMICONDUCTOR DEVICE
)
) Group Art Unit: 2823
)
) Examiner: N. Berezny
)
)

TECHNOLOGY CENTER 2800

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OCT 23 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL LETTER

Dear Sir:

Please find enclosed the following documents pertaining to the above-referenced application:

1. Response to Office Action (9 pages);
2. Petition for Extension of Time Under 37 C.F.R. 1.136(a) (in duplicate);
3. Check for \$110.00 (1 mo. extension fee);
4. Return Receipt Postcard

The Commissioner is hereby authorized to charge any necessary fees to Deposit Account 232126. In the event of non-payment or improper payment of a require fee, the Commissioner is hereby authorized to charge or credit Deposit Account No. 232126 as required to correct the error. A duplicate copy of this letter is enclosed for fee purposes.

Respectfully submitted

By:

Douglas S. Rupert
Attorney for Applicant
Reg. No. 44,434

Date: 10/16/03
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CERTIFICATE OF EXPRESS MAIL

'Express Mail' mailing label number: ER 02250149918
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I hereby certify that this paper or fee is being deposited with the
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22313-1450.